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| Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary) | Atty Docket No. | GENSP107 |
| | Application No.: | 10/726,362 |
| | Applicant | Osamu Kobayashi |
| | Filing Date | December 2, 2003 |
| | Group | Unassigned |
| | | Page 1 of 3 |

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| Examiner Initial | | Document No. | Publication Date | Country or Patent Office | Class | Sub-Class | Translation | |
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| | 10. | CN 1353513 | 06-12-02 | CN | | | | |
| | 11. | EP 1 473 700 | 11-03-04 | EP | | | | |
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| | 13. | Office Action dated April 4, 2008 in CN Patent Application No. 200410043419.1 |
| | 14. | Office Action dated August 19, 2008 from U.S. Application No. 10/726,440 |
| | 15. | Search Report dated July 2, 2008 in EP Application No. 08155263.0 |
| | 16. | Search Report dated June 30, 2008 in EP Application No. 08155262.2 |
| | 17. | Notice of Allowance dated October 1, 2008 in US Application No. 10/909,085 |
| | 18. | Office Action dated October 16, 2008 in US Application No. 10/909,027 |

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| Examiner | Date Considered |
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| | 20. | Office Action dated September 12, 2008 in CN Patent Application No. 200410044503.5 |
| | 21. | Office Action dated June 24, 2008 from U.S. Application No. 10/726,794 |
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| | 40. | Office Action dated August 8, 2008 from Chinese Patent Application No. 200410045686.2 |
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| | 42. | VESA Display Port Standard, Version 1.1, March 19, 2007. |
| | 43. | Office Action dated August 6, 2008 from U.S. Application No. 10/726,895 |
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